

In re Applicant:

Chris E. Barns et al.

Art Unit:

2822

Serial No.:

10/629,127

9999999 Examiner:

Khanh B. Duong

Filed:

July 29, 2003

For:

Preventing Silicide Formation at

the Gate Electrode in a Replacement

Metal Gate Technology

Docket:

ITL.1016US

P16703

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT ACCOMPANYING RCE

Sir:

This paper is submitted in conjunction with the enclosed Request for Continuing Examination (RCE) in the above-identified Patent Application. Further examination and reconsideration are respectfully requested in view of the Amendments set forth below.

Amendments to the Claims begin on page 2 of this paper.

Date of Deposit: January 11, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, operia, YA 22313-1450.

Tén Peacock